## DATA SHEET (分新特光电



## S6EXK0010/292 **Beamexpander**

- magnification 1.0x
- for 515 nm 545 nm
- fused silica
- low absorption coating





## DATA SHEET



specifications	
article number	S6EXK0010/292
design wavelength [nm]	532
magnification factor	1.0x
divergence adjustable	$\checkmark$
optical principle	Galilei (no internal focus)
mounting thread	M30x1
pointing stability [mrad]	<1
clear input aperture [mm]	12.0
clear output aperture [mm]	14.0
max. input beam diameter [mm]	10.0
wavefront error <sup>1)</sup>	$<\lambda/10$ for $1/e^2$ diameter <sup>2)</sup> of 10.0
total number of lenses	3
total transmission [%]	98
lens material	fused silica
LIDT (coating) [J/cm <sup>2</sup> ]	2.5 (1ns pulse at 50Hz)
no internal ghosts [ $\checkmark$ /×]	$\checkmark$
no internal ghosts, reversed usage	$\checkmark$
weight [kg]	0.30
accessory	S6MEC0107 - adapter M30x1 to C-mount

notes	
<ol> <li>Wavefront error peak to valley on axis proved by design</li> <li>beam diameter vignetted at 1/e<sup>2</sup></li> </ol>	
Data given by design	
LIDT = Laser Induced Damage Threshold, valid for the coating at design wavelength and gaussian intensity profil	
length at divergence setting "0". Max. lengthening of 3 mm is possible	